

00862.021856.

## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

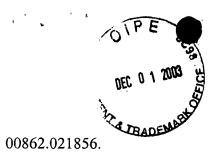
In re Application of: Hiroshi TANAKA					Examiner: S. C. Chawan  Group Art Unit: 2625  Confirmation No.: 1390				
Application No.: 09/521,210									
Filed: March 8, 2000									
For: POSITION DETECTION APPARATUS AND EXPOSURE APPARATUS				; ) ;	December 1, 2003 (Monday) RECEIVED				
Commissioner for Patents						DE	C 0 2 2003		
P.O. Box 1450 Alexandria, VA 22313-1450						•	ogy Center 2600		
Sir:									
Transmitted herewith is an Amendment in the above-identified application.									
X No additional fee is required.									
The fee has been calculated as shown below:									
			CLAIMS AS AM	<u>IENDEI</u>	)	1			
_	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	]	PRESENT EXTRA	RATE	ADDITIONAL FEE		
TOTAL CLAIMS	24	MINUS	36	=	0	x \$9 \$18	\$0.00		
INDEP. CLAIMS	4	MINUS	6	=	0	x \$42 \$84	\$0.00		
Fee for Multiple Dependent claims \$140/\$280						<del></del>			
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT							\$0.00		
	fied Statement c					_			

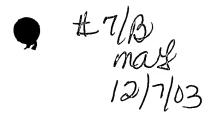
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.						
• •	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.						
· 	A check in the amount of \$ to cover the fee for a month extension is enclosed.						
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.						
X	Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.						
	Respectfully submitted,						
	Attorney for Applicant Steven E. Warner Registration No. 33,326						
30 Rocke New Yor	FRICK, CELLA, HARPER & SCINTO efeller Plaza rk, New York 10112-3801						

Facsimile: (212) 218-2200

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Commissioner for Detents		

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

DEC 0 2 2003

**Technology Center 2600** 

#### **AMENDMENT**

Sir:

In response to the Official Action dated August 29, 2003, please amend the aboveidentified application as follows: